

Monday, 28 June 2021

9:00-9:15	Conference Opening
9:15-10:00	<p>New Challenges of Printed High-κ Oxide Dielectrics E. Carlos, R. Branquinho, R. Martins, <u>E. Fortunato</u> CENIMAT/i3N Departamento de Ciência dos Materiais, Faculdade de Ciências e Tecnologia (FCT), Universidade NOVA de Lisboa (UNL), and CEMOP/UNINOVA, Caparica, Portugal</p>
10:00-10:45	<p>20 Years of Reconfigurable Field-Effect Transistors: From Concepts to Future Applications <u>T. Mikolajick</u>^{1,2}, G. Galderisi¹, M. Simon¹, S. Rai³, A. Kumar³, A. Heinzig², W. M. Weber⁴, J. Trommer¹ ¹NaMLab gGmbH, Dresden, Germany ²Chair for Nanoelectronics, TU Dresden, Dresden, Germany ³Chair for Processor design, Center for Advancing Electronics Dresden, TU Dresden, Dresden, Germany ⁴Institute of Solid State Electronics, TU Wien, Vienna, Austria</p>
10:45-11:15	Break
<p>Dielectrics for MIM and DRAM Chair: C. Dubourdieu, Helmholtz Zentrum Berlin, Germany</p>	
11:15-11:30	<p>Opportunity for Band Alignment Manipulation of Perovskite Oxide Stacks by Interfacial Dipole Layer Formation <u>A. Tamura</u>¹, S. Jang², Y.-G. Park², H. Lim², K. Kita¹ ¹Dept. of Materials Engineering, The Univ. of Tokyo, Tokyo, Japan ²Semiconductor R&D Center, Samsung Electronics, Gyeonggi-do, Korea</p>
11:30-11:45	<p>Poly(V₃D₃), an iCVD Polymer with Promising Dielectric Properties for High Voltage Capacitors <u>C. Zavvou</u>, J. Cluzel, D. Mariolle, A. Lefevre, V. Jousseume ¹Univ. Grenoble Alpes, CEA, Leti, Grenoble, France</p>
11:45-12:00	<p>Fabrication and Modelling of MIM Diodes with Low Turn-On Voltage <u>I. Nemr Noureddine</u>¹, N. Sedghi¹, J. Wrench², P. Chalker², I. Z. Mitrovic¹, S. Hall¹ ¹Dept. of Electrical Engineering and Electronics, University of Liverpool, Liverpool, UK ²Centre for Advanced Materials, School of Engineering, University of Liverpool, Liverpool, UK</p>
12:00-12:15	<p>Applicability of Sc₂O₃ Versus Al₂O₃ in MIM Rectifiers for IR Rectenna <u>S. Almalki</u>, S. B. Tekin, N. Sedghi, S. Hall, I. Z. Mitrovic Dept. of Electrical Engineering and Electronics, University of Liverpool, Liverpool, UK</p>
12:15-14:15	Break
<p>2D materials (I) Chair: V. Afanas'ev, KU Leuven, Belgium</p>	
14:15-14:45	<p>Crystalline Insulators for Scalable 2D Nanoelectronics <u>Y. Y. Illarionov</u>^{1,2}, T. Knobloch¹, T. Grasser¹ ¹Institute for Microelectronics (TU Wien), Vienna, Austria ²Toffe Institute, St-Petersburg, Russia</p>

14:45-15:00	<p>Investigating Interface States and Oxide Traps in the MoS₂/Oxide/Si System</p> <p><u>E. Coleman</u>¹, G. Mirabelli¹, P. Bolshakov², P. Zhao², E. Caruso¹, F. Gity¹, S. Monaghan¹, K. Cherkaoui, R. M. Wallace², C. D. Young², R. Duffy¹, P. K. Hurley¹</p> <p>¹Tyndall National Institute, University College Cork, Cork, Ireland ²Department of Materials Science and Engineering, University of Texas at Dallas, Richardson, TX, USA</p>
15:00-15:15	<p>Simulation Study of Fermi Level Depinning in Metal-MoS₂ Contacts</p> <p><u>P. Khakbaz</u>¹, F. Driussi¹, P. Giannozzi^{1,2}, A. Gambi¹, D. Esseni¹</p> <p>¹Università degli Studi di Udine, Udine, Italy ²CNR-IOM, Istituto dell'Officina dei Materiali, SISSA, Trieste, Italy</p>
15:15-15:30	Break
<p>2D materials (II)</p> <p>Chair: P. Hurley, Tyndall National Institute, Ireland</p>	
15:30-15:45	<p>Optical Transitions in Monolayer WS₂ Observed through Transient Photoconductivity in MIS Structures</p> <p><u>G. Delie</u>, I. Shlyakhov, K. Iakoubovskii, S. Achra, V. V. Afanas'ev</p> <p>Department of Physics and Astronomy, KU Leuven, Leuven, Belgium</p>
15:45-16:00	<p>Interface Admittance Measurement and Simulation of Dual Gated CVD WS₂ MOSCAPs: Mapping the D_{IT}(E) Profile</p> <p><u>V. Mootheri</u>^{1,2}, X. Wu¹, D. Cott¹, B. Groven¹, M. Heyns^{1,2}, I. Asselberghs¹, I. Radu¹, D. Lin¹</p> <p>¹IMEC, Leuven, Belgium ²KU Leuven, Leuven, Belgium</p>
16:00-16:15	<p>Assessment of 2D-FET Based Digital and Analog Circuits on Paper</p> <p><u>M. Vatalaro</u>¹, R. De Rose¹, M. Lanuzza¹, G. Iannaccone², F. Crupi¹</p> <p>¹DIMES, University of Calabria, Rende, Italy ²Dipartimento di Ingegneria dell'Informazione, University of Pisa, Pisa, Italy</p>
16:15-16:30	<p>Quantum Capacitance Transient Phenomena in High-K Dielectric Armchair Graphene Nanoribbon Field-Effect Transistor Model</p> <p><u>A. Avnon</u>¹, R. Golman¹, E. Garzón^{1,2}, H.-D. Ngo³, M. Lanuzza², A. Teman¹</p> <p>¹Enics, Faculty of Engineering, Bar-Ilan University, Ramat Gan, Israel ²DIMES, University of Calabria, Rende, Italy ³IZM Fraunhofer Institute, Berlin, Germany</p>

Tuesday, 29 June 2021

Ferroelectrics and functional oxides

Chair: J. Robertson, University of Cambridge, UK

9:00-9:30	HfO₂-Based Ferroelectric Devices for Diverse Applications <u>R. Huang</u> Peking University, Peking, China
9:30-10:00	CMOS Back-End-Of-Line Compatible Ferroelectric Tunnel Junction Devices <u>V. Deshpande</u> ¹ , K. S. Naira ² , M. Holzer ^{1,2} , S. Banerjee ¹ , C. Dubourdieu ^{1,2} ¹ Helmholtz-Zentrum Berlin für Materialien und Energie, Berlin, Germany ² Freie Universität Berlin, Physical Chemistry, Berlin, Germany
10:00-10:15	Evidence of Ferroelectric HfO₂ Phase Transformation Induced by Electric Field Cycling Observed at a Macroscopic Scale <u>S. Nittayakasetwat</u> , K. Kita Department of Materials Engineering, Graduate School of Engineering, University of Tokyo, Tokyo, Japan
10:15-10:30	Electron Trapping in Ferroelectric HfZrO₄ and Al- and Si-Doped Layers <u>R. A. Izmailov</u> ¹ , B. J. O'Sullivan ² , M. Popovici ² , V. V. Afanas'ev ¹ ¹ KU Leuven, Leuven, Belgium ² IMEC, Leuven, Belgium
10:30-11:00	Break
Materials for non-volatile memories (I) Chair: S. Strangio, University of Pisa, Italy	
11:00-11:15	Role of Temperature, MTJ Size and Pulse-Width on STT-MRAM Bit-Error Rate and Backhopping <u>J. Tan</u> ^{1,2} , J. H. Lim ^{1,2} , J. H. Kwon ¹ , V.B. Naik ¹ , N. Raghavan ² , K. L. Pey ² ¹ GLOBALFOUNDRIES Singapore Pte. Ltd., Singapore ² Singapore University of Technology and Design, Singapore
11:15-11:30	Relaxing Non-Volatility for Energy-Efficient DMTJ Based Cryogenic STT-MRAM <u>E. Garzón</u> ^{1,2} , R. De Rose ¹ , Felice Crupi ¹ , Lionel Trojman ³ , Adam Teman ² , Marco Lanuzza ¹ ¹ DIMES, University of Calabria, Rende, Italy ² Enics, Faculty of Engineering, Bar-Ilan University, Ramat Gan, Israel ³ LISITE, ISEP - Institut Supérieur d'Électronique de Paris, Paris, France
11:30-11:45	Effect of the Switching Layer on CBRAM Reliability and Benchmarking Against OxRAM Devices <u>A. Belmonte</u> ¹ , G. Reale ^{1,2} , A. Fantini ¹ , J. Radhakrishnan ^{1,3} , A. Redolfi ¹ , W. Devulder ¹ , L. Nyns ¹ , S. Kundu ¹ , R. Delhougne ¹ , L. Goux ¹ , G. S. Kar ¹ ¹ IMEC, Leuven, Belgium ² University of Calabria, Rende, Italy ³ Department of Semiconductor Physics, KU Leuven, Leuven, Belgium

11:45-12:00	<p>SPICE Modeling of Cycle-to-Cycle Variability in RRAM Devices</p> <p><u>E. Salvador</u>¹, M. B. Gonzalez², F. Campabadal², J. Martin-Martinez¹, R. Rodriguez¹, E. Miranda¹</p> <p>¹Departament d'Enginyeria Electrònica, Universitat Autònoma de Barcelona, Cerdanyola del Valles, Spain ²Institut de Microelectrònica de Barcelona, IMB-CNM, CSIC, Cerdanyola del Valles, Spain</p>
12:00-12:15	<p>Structural and Electronic Rearrangement in Ovonic Switching GexSe_{1-x}(0.4<x<0.72) Films</p> <p><u>A. S. Konashuk</u>¹, E. O. Filatova¹, A. A. Sokolov², V. V. Afanas'ev³, M. Houssa³, A. Stesmans³</p> <p>¹Institute of Physics, St. Petersburg State University, St. Petersburg, Russia ²Helmholtz-Zentrum Berlin für Materialien und Energie GmbH, Berlin, Germany ³Department of Physics, KU Leuven, Leuven, Belgium</p>
12:15-12:30	<p>Study of the Set and Reset Transitions in HfO₂-Based ReRAM Devices Using a Capacitor Discharge</p> <p><u>H. García</u>¹, G. Vinuesa¹, O. G. Ossorio¹, B. Sahelices², H. Castán¹, S. Dueñas¹, M. B. González³, F. Campabadal³</p> <p>¹Dpto. Electricidad y Electrónica, University of Valladolid, Valladolid, Spain ²Dpto. Informática, University of Valladolid, Valladolid, Spain ³Institut de Microelectrònica de Barcelona, IMB-CNM (CSIC), Bellaterra, Spain</p>
12:30-14:30	Break
<p>Materials for non-volatile memories (II)</p> <p>Chair: T. Ando, IBM, USA</p>	
14:30-14:45	<p>Enhanced Serial RRAM Cell for Unpredictable Bit Generation</p> <p><u>R. Rodríguez-Montañés</u>¹, D. Arumí¹, A. Gómez-Pau¹, S. Manich¹, M. B. Gonzalez², F. Campabadal²</p> <p>¹Departament d'Enginyeria Electrònica, Universitat Politècnica de Catalunya, Barcelona, Spain ²Institut de Microelectrònica de Barcelona, IMB-CNM (CSIC), Bellaterra, Spain</p>
14:45-15:00	<p>Effective Control of Filament Efficiency by Means of Spacer HfAlO_x Layers and Growth Temperature in HfO₂ Based ReRAM Devices</p> <p><u>G. Vinuesa</u>¹, O. G. Ossorio¹, H. García¹, B. Sahelices¹, H. Castán¹, S. Dueñas¹, M. Kull², A. Tarre², T. Jõgiaas², A. Tamm², K. Kukli²</p> <p>¹Dpto. Electricidad y Electrónica, University of Valladolid, Valladolid, Spain ²Institute of Physics, University of Tartu, Tartu, Estonia</p>
15:00-15:15	<p>STT-MTJ Based Smart Implication for Energy-Efficient Logic-in-Memory Computing</p> <p><u>R. De Rose</u>¹, T. Zanotti², F. M. Puglisi², F. Crupi¹, P. Pavan², M. Lanuzza¹</p> <p>¹DIMES, University of Calabria, Rende, Italy ²DIEF, University of Modena and Reggio Emilia, Modena, Italy</p>

15:15-15:30	<p>Analysis of the Performance of Nb₂O₅-Doped SiO₂-Based MIM Devices for Memory and Neural Computation Applications</p> <p><u>O. G. Ossorio</u>¹, G. Vinuesa¹, H. García¹, B. Sahelices¹, S. Dueñas¹, H. Castán¹, M. Ritala², M. Leskelä², K. Kukli³</p> <p>¹Dpto. Electricidad y Electrónica, University of Valladolid, Valladolid, Spain ²Department of Chemistry, University of Helsinki, Helsinki, Finland ³Institute of Physics, University of Tartu, Tartu, Estonia</p>
15:30-15:45	<p>A Simple, Robust, and Accurate Compact Model for a Wide Variety of Complementary Resistive Switching Devices</p> <p><u>M. Saludes-Tapia</u>¹, M. B. Gonzalez², F. Campabadal², J. Suñé¹, E. Miranda¹</p> <p>¹Departament d'Enginyeria Electrònica, Universitat Autònoma de Barcelona, Cerdanyola del Valles, Spain ²Institut de Microelectrònica de Barcelona, IMB-CNM, CSIC, Cerdanyola del Valles, Spain</p>
15:45-16:00	<p>Stochastic Based Compact Model to Predict Highly Variable Electrical Characteristics of Organic CBRAM</p> <p><u>S. Guitarra</u>¹, P. Mahato², D. Deleruyelle², L. Raymond³, L. Trojman^{1, 4}</p> <p>¹Colegio de Ciencias e Ingeniería, IMNE, Universidad San Francisco de Quito, Quito, Ecuador ²Institut des Nanotechnologies de Lyon UMR CNRS, Institut National des Sciences Appliquées de Lyon, Villeurbanne, France ³Aix Marseille Université, Université de Toulon, CNRS, CPT, Marseille, France ⁴LISITE, ISEP - Institut Supérieur d'Électronique de Paris, Paris, France</p>

Wednesday, 30 June 2021

Materials for neuromorphic computing

Chair: S. Slesazeck, NaMLab, Germany

9:00-9:30	From Resilience to Resistive Memory Variability in Binarized Neural Networks to Exploitation of Variability in Bayesian Neural Network <u>T. Hirtzlin</u> CEA-Leti, Grenoble, France
9:30-9:45	Single-Poly Floating-Gate Memory Cell Options for Analog Neural Networks <u>M. Paliy</u> , T. Rizzo, P. Ruiu, S. Strangio, G. Iannaccone Dipartimento di Ingegneria dell'Informazione, University of Pisa, Pisa, Italy
9:45-10:00	Microstructure Scaling in Metal-Insulator-Transitions of Atomic Layer Deposited VO₂ Films K. Niang, G. Bai, H. Lu, <u>J. Robertson</u> Engineering Dept., Cambridge University, Cambridge, UK
10:00-10:15	Influence of Variability on the Performance of HfO₂ Memristor-Based Convolutional Neural Networks R. Romero-Zalaz ¹ , E. Pérez ² , F. Jimenez-Molinos ³ , C. Wenger ^{2,4} , <u>J. B. Roldán</u> ³ ¹ DaSCI, Granada University, Granada, Spain ² IHP-Leibniz-Institut für innovative Mikroelektronik, Frankfurt, Germany ³ Departamento de Electrónica y Tecnología de Computadores, Universidad de Granada, Granada, Spain ⁴ BTU Cottbus-Senftenberg, Cottbus, Germany
10:15-10:30	Robustness of Using Degree Of Match in Performing Analog Multiplication with Spin-Torque Oscillators <u>L. Mazza</u> ¹ , V. Puliafito ² , M. Carpentieri ¹ , G. Finocchio ³ ¹ Department of Electrical and Information Engineering, Politecnico of Bari, Bari, Italy ² Department of Engineering, University of Messina, Messina, Italy ³ Department of Mathematical and Computer Sciences, Physical Sciences and Earth Sciences, University of Messina, Messina, Italy
10:30-11:15	Break
Dielectrics for power devices (I) Chair: K. Kita, University of Tokyo, Japan	
11:15-11:45	Current Status of Lateral and Vertical Ga₂O₃ FET Technologies <u>M. Higashiwaki</u> National Institute of Information and Communications Technology, Koganei, Japan
11:45-12:00	Flat-Band Voltage Shift of 4H-SiC MOS Capacitors Induced by Interface Dipole Layer Formation at the Oxide-Semiconductor and Oxide-Oxide Interfaces <u>T.-H. Kil</u> ¹ , M. Noguchi ² , H. Watanabe ² , K. Kita ¹ ¹ Department of Materials Engineering, The University of Tokyo, Tokyo, Japan ² Advanced Technology R&D Center, Mitsubishi Electric Corporation, Amagasaki, Hyogo, Japan

12:00-12:15	<p>Mobility Degradation in 4H-SiC MOSFETs and Interfacial Formation of Carbon Clusters</p> <p>Z. Zhang¹, Y. Guo², <u>J. Robertson</u>¹</p> <p>¹Engineering Dept., Cambridge University, Cambridge, UK ²Electrical Engineering and Automation, Wuhan University, Wuhan, China</p>
12:15-12:30	<p>TCAD Modeling of Bias Temperature Instabilities in SiC MOSFETs</p> <p>G. Carangelo¹, <u>S. Reggiani</u>¹, G. Consentino², F. Crupi², G. Meneghesso³</p> <p>¹ARCES and DEI, University of Bologna, Bologna, Italy ²DIMES, University of Calabria, Rende, Italy ³DEI, University of Padova, Padova, Italy</p>
12:30-14:30	Break
<p>Dielectrics for power devices (II)</p> <p>Chair: J. Franco, IMEC, Belgium</p>	
14:30-15:00	<p>High Performance p-Channel GaN/AlN FETs for Wide-Bandgap CMOS</p> <p><u>D. Jena</u></p> <p>Cornell University, Ithaca, United States</p>
15:00-15:15	<p>Low-Frequency Noise Investigation of AlGaN/GaN High-Electron-Mobility Transistors</p> <p>M. G. Caño de Andrade¹, <u>L. F. de Oliveira Bergamim</u>¹, B. Baptista Júnior¹, C. R. Nogueira¹, F. A. da Silva¹, K. Takakura², B. Parvais^{3,4}, Eddy Simoen³</p> <p>¹Institute of Science and Technology, São Paulo State University, Sorocaba, Brazil ²Dept. of Information, Commun. and Electron. Eng., National Inst. of Technol., Kumamoto, Japan ³IMEC, Leuven, Belgium ⁴ETRO Department, Vrije Universiteit Brussels, Brussels, Belgium</p>
15:15-15:30	<p>Barrier Height Tuning in Ti/4H-SiC Schottky Diodes</p> <p><u>G. Bellocchi</u>¹, M. Vivona², S. Rascunà¹, F. Roccaforte²</p> <p>¹STMicroelectronics, Catania, Italy ²CNR-IMM, Catania, Italy</p>
15:30-15:45	<p>Analog Performance of GaN/AlGaN High-Electron-Mobility Transistors</p> <p><u>L. F. de Oliveira Bergamim</u>¹, Bertrand Parvais^{2,3}, Eddy Simoen², M. G. Caño de Andrade¹</p> <p>¹Institute of Science and Technology, São Paulo State University, Sorocaba, Brazil ²IMEC, Leuven, Belgium ³ETRO Department, Vrije Universiteit Brussels, Brussels, Belgium</p>

Thursday, 1 July 2021

Electrical reliability and modelling

Chair: R. De Rose, University of Calabria, Italy

9:00-9:15	A Multi-Energy Level Agnostic Simulation Approach to Defect Generation <u>A. Vici</u> ^{1,2} , R. Degraeve ² , B. Kaczer ² , J. Franco ² , S. Van Beek ² , I. De Wolf ^{2,3} ¹ Dept. Electrical Engineering, KU Leuven, Leuven, Belgium ² IMEC, Leuven, Belgium ³ Dept. Material Science, KU Leuven, Leuven, Belgium
9:15-9:30	Understanding the Impact of Split-Gate LDMOS Transistors: Analysis of Performance and Hot-Carrier-Induced Degradation <u>P. Magnone</u> ¹ , A. N. Tallarico ² , S. Pistollato ¹ , R. Depetro ³ , G. Croce ³ ¹ DTG, University of Padova, Vicenza, Italy ² ARCES and DEI, University of Bologna, Cesena, Italy ³ Technology R/D, STMicroelectronics, Agrate Brianza, Italy
9:30-9:45	Statistical Threshold Voltage Shifts Caused by BTI and HCI at Nominal and Accelerated Conditions <u>J. Diaz-Fortuny</u> ¹ , P. Saraza-Canflanca ² , R. Rodriguez ¹ , J. Martin-Martinez ¹ , R. Castro-Lopez ² , E. Roca ² , F. V. Fernandez ² , M. Nafria ¹ ¹ Electronic Engineering Department, Universitat Autònoma de Barcelona, Barcelona, Spain ² Instituto de Microelectrónica de Sevilla, IMSE-CNM, CSIC and Universidad de Sevilla, Sevilla, Spain
9:45-10:00	Unified RTN and BTI Statistical Compact Modeling from a Defect-Centric Perspective <u>G. Pedreira</u> ¹ , J. Martin-Martinez ¹ , P. Saraza-Canflanca ² , R. Castro-Lopez ² , R. Rodriguez ¹ , E. Roca ² , F. V. Fernandez ² , M. Nafria ¹ ¹ Electronic Engineering Department, Universitat Autònoma de Barcelona, Barcelona, Spain ² Instituto de Microelectrónica de Sevilla, IMSE-CNM, CSIC and Universidad de Sevilla, Sevilla, Spain
10:00-10:15	Investigation of the Anomalous Effect of the AC-Signal Frequency on Flat-Band Voltage of Al/HfO₂/SiO₂/Si Structures <u>A. Mazurak</u> , B. Majkusiak Institute of Microelectronics and Optoelectronics, Warsaw University of Technology, Warsaw, Poland
10:15-10:30	Computational Study of Group III-V Semiconductors and Their Interaction with Oxide Thin Films L. A. Cipriano, G. Di Liberto, <u>S. Tosoni</u> Dipartimento di Scienza dei Materiali, Università di Milano-Bicocca, Milan, Italy
10:30-11:00	Break

Characterization techniques (I)

Chair: V. Afanas'ev, KU Leuven, Belgium

11:00-11:15	<p>Cryogenic Temperature DC-IV Measurements and Compact Modelling of N-channel Bulk FinFETs with 3-4nm Wide Fins and 20nm Gate Length for Quantum Computing Applications</p> <p><u>S. Gupta</u>¹, A. Rathi¹, B. Parvais^{2,3}, A. Dixit¹</p> <p>¹Department of Electrical Engineering, IIT Delhi, New Delhi, India ²IMEC, Leuven, Belgium ³ETRO Department, Vrije Universiteit Brussels, Brussels, Belgium</p>
11:15-11:30	<p>Study of RTN Signals in Resistive Switching Devices Based on Neural Networks</p> <p>G. González-Cordero¹, M. B. González², M. Zabala², K. Kalam³, A. Tamm³, <u>F. Jiménez-Molinos</u>¹, F. Campabadal², J. B. Roldán¹</p> <p>¹Departamento de Electrónica y Tecnología de Computadores, Universidad de Granada, Granada, Spain ²Institut de Microelectrònica de Barcelona, IMB-CNM (CSIC), Bellaterra, Spain ³Institute of Physics, University of Tartu, Tartu, Estonia</p>
11:30-11:45	<p>Exploiting the KPFM Capabilities to Analyze at the Nanoscale the Impact of Electrical Stresses on OTFTs Properties</p> <p><u>A. Ruiz</u>¹, S. Claramunt¹, A. Crespo¹, M. Porti¹, M. Nafria¹, H. Xu², C. Liu², Q. Wu²</p> <p>¹Electronic Engineering Department, Universitat Autònoma de Barcelona, Barcelona, Spain ²School of Electronics and Information technology, Sun Yat-Sen University, Guangzhou, China</p>
11:45-12:00	<p>Custom Measurement System for Memristor Characterisation</p> <p><u>F. V. Lupo</u>¹, D. Scirè¹, M. Mosca¹, I. Crupi¹, L. Razzari², R. Macaluso¹</p> <p>¹Department of Engineering, Università degli Studi di Palermo, Palermo, Italy ²Institut National de la Recherche Scientifique - Centre Énergie Matériaux Télécommunications, Montréal, Canada</p>
12:00-14:30	Break
<h2>Characterization techniques (II)</h2> <p>Chair: C. Leroux, CEA-LETI Grenoble, France</p>	
14:30-14:45	<p>On the Interpretation of MOS Impedance Data in Both Series and Parallel Circuit Topologies</p> <p>E. Caruso^{1,4}, J. Lin¹, S. Monaghan¹, K. Cherkaoui¹, L. Floyd¹, F. Gity¹, P. Palestri², D. Esseni², L. Selmi³, <u>P. K. Hurley</u>¹</p> <p>¹Tyndall National Institute, University College Cork, Cork, Ireland ²DPIA, University of Udine, Udine, Italy ³DIEF, University of Modena and Reggio Emilia, Modena, Italy ⁴Infineon Technologies, Villach, Austria</p>
14:45-15:00	<p>Shallow Electron Traps in High-k Insulating Oxides</p> <p><u>R. A. Izmailov</u>¹, B.J. O'Sullivan², M. Popovici², J.A. Kittl¹, V.V. Afanas'ev¹</p> <p>¹KU Leuven, Leuven, Belgium ²IMEC, Leuven, Belgium</p>

15:00-15:15	<p>A Simple Test Structure for the Electrical Characterization of Front and Back Channels for Advanced SOI Technology Development</p> <p><u>M. Alepidis</u>¹, I. Ionica¹, F. Milesi², N. Bresson², G. Gaudin³, S. Cristoloveanu¹, S. Reboh²</p> <p>¹University Grenoble Alpes, Grenoble INP, IMEP-LaHC, Grenoble, France ²CEA, Leti, Minatec Campus, and University Grenoble Alpes, Grenoble, France ³SOITEC, Parc Technologique des Fontaines, Bernin, France</p>
15:15-15:30	<p>Characterization of Defect Density States in MoO_x for c-Si Solar Cell Applications</p> <p><u>D. Scirè</u>¹, R. Macaluso¹, M. Mosca¹, S. Mirabella², A. Gulino³, O. Isabella⁴, M. Zeman⁴, I. Crupi¹</p> <p>¹Department of Engineering, University of Palermo, Palermo, Italy ²Department of Physics and Astronomy, University of Catania, Catania, Italy ³Department of Chemical Sciences, University of Catania, Catania, Italy ⁴Photovoltaic Materials and Devices group, Delft University of Technology, Delft, the Netherland</p>
15:30-15:45	<p>Harnessing Charge Injection in Kelvin Probe Force Microscopy for the Evaluation of Oxides</p> <p><u>U. Celano</u>^{1, 2}, Y. Lee³, J. Serron¹, C. Smith¹, J. Franco¹, P. van der Heide¹</p> <p>¹IMEC, Leuven, Belgium ²Faculty of Science and Technology, University of Twente, Enschede, The Netherlands ³Samsung Electronics Co., Ltd.</p>

Friday, 2 July 2021

9:00-9:30	Ferroelectric HfO₂ Based Memory Technology <u>M. Liu</u> Institute of Microelectronics of Chinese Academy of Sciences, Peking, China
9:30-10:00	Compound Semiconductor Devices for 5G Applications and Beyond <u>N. Collaert</u> IMEC, Leuven, Belgium
10:00-10:30	Nanolayer Boron-Semiconductor Interfaces and Their Device Applications <u>L. K. Nanver</u> ¹ , L. Qi ² , X. Liu ¹ , T. Knežević ¹ ¹ MESA+ Institute for Nanotechnology, University of Twente, Enschede, The Netherlands ² Delft University of Technology, Delft, The Netherlands
10:30-11:00	Break
11:00-11:15	Best Student Paper Award
11:15-11:30	Conference Closing